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In re Application of  
Selvamanickam  
Serial Number: 10/602,467  
Filed: June 23, 2003  
For: APPARATUS FOR HIGH-THROUGHPUT ION  
BEAM-ASSISTED DEPOSITION (IBAD)

PETITION UNDER  
M.P.E.P.708.02 IX

This is in response to the petition filed February 12, 2004, requesting that the above-identified application be granted Special Status under Section 708.02 IX of the MPEP and 37 CFR 1.102 (b) (**no fee required**).

The request for Special Status considered under Section 708.02 IX of the MPEP is granted because criteria under 37 CFR 1.102(b) has been met.

Accordingly the petition is **GRANTED**.

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